

<b>Notice of References Cited</b>	Application/Control No. 10/559,847	Applicant(s)/Patent Under Reexamination CRIVELLO, JAMES V.	
	Examiner Bernard Dentz	Art Unit 1625	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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	C	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Crivello et al, Radtech Conference Proceedings, p.432-445 (1990)
	V	
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